

## COPY OF PAPERS **ORIGINALLY FILED**

[10191/1

TED STATES PATENT AND TRADEMARK OFFIC

Inventors

Dieter SEIPLER et al.

Serial No.

09/837,127

Filed

April 18, 2001

For

METHOD FOR MANUFACTURING PIEZOELECTRIC ACTUATORS AND A PIEZOELECTRIC ACTUATOR

Examiner

Budd, M

Art Unit

2834

Assistant Commissioner

of Patents

Washington, D.C. 20231

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner of Patents, Washington,

D.C. 20231 on

Date: February\_1/2002

Rea. No. 36,197

Signature: Jong H. Lee

## **AMENDMENT**

## S T R:

In response to the Office Action mailed on October 18, 2001, kindly amend the above-captioned application before examination as follows:

## N THE CLAIMS

Please cancel claims 14 to 17 and add the following new claims 18 to 26 as follows:

--18. (New) A method for the parallel manufacturing of a plurality of piezoelectric actuators, comprising the steps of:

manufacturing a plurality of thin foils made of an unfired, piezoelectric ceramic material;

forming a plurality of pairs of openings through the foils, each pair of openings consisting of a first connecting opening and a second connecting opening, each pair of openings being assigned to one of the actuators;